

IN THE CLAIMS

All claims and status identifiers have been reproduced below.

1. (original) An apparatus for inspecting a disc-like substrate comprising a holding structure having members arranged to hold and rotate the substrate about a first axis, the holding structure being coupled to a rotatable member, the rotatable member configured to rotate the holding structure about a second axis different from the first axis.

2. (original) The apparatus, as set forth in claim 1, wherein the members comprise a plurality of wedge assemblies configured to rotate the substrate about the first axis.

3. (original) The apparatus, as set forth in claim 1, wherein the first axis is disposed generally perpendicular to a flat surface of the substrate and extends generally through an axial center of the substrate.

4. (original) The apparatus, as set forth in claim 1, wherein the holding structure comprises two L-shaped gripping arms arranged to form a single U-shaped structure and configured to hold the substrate substantially parallel to the gripping arms.

5. (original) The apparatus, as set forth in claim 4, wherein the U-shaped structure is configured to open and close about the perimeter of the substrate.

6. (original) The apparatus, as set forth in claim 5, further comprising tensioning springs configured to permit the U-shaped structure to open and close about the perimeter of the substrate.

7. (original) The apparatus, as set forth in claim 2, wherein the holding structure comprises three wedge assemblies, at least one wedge assembly coupled to a motor and configured to rotate the substrate about the first axis disposed generally perpendicular to a flat surface of the substrate and extending generally through an axial center of the substrate.

8. - 21. (canceled).